PATENT

Attorney Docket No.: 021713-000400US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Examiner:

Xiao Yang

, of of 1, , , w

Art Unit:

Application No.:

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR §1.97 and

§1.98

Filed:

For: METHOD AND APPARATUS TO REDUCE PARASITIC FORCES IN ELECTRO-MECHANICAL SYSTEMS

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

The references cited on attached form PTO/SB/08A and PTO/SB/08B are being called to the attention of the Examiner. Copies of the references are enclosed. It is respectfully requested that the cited references be expressly considered during the prosecution of this application, and the references be made of record therein and appear among the "references cited" on any patent to issue therefrom.

As provided for by 37 CFR 1.97(g) and (h), no inference should be made that the information and references cited are prior art merely because they are in this statement and no representation is being made that a search has been conducted or that this statement encompasses all the possible relevant information.

Applicant believes that <u>no fee is required</u> for submission of this statement. However, if a fee is required, the Commissioner is authorized to deduct such fee from the undersigned's Deposit Account No. 20-1430. Please deduct any additional fees from, or credit any overpayment to, the above-noted Deposit Account.

Xiao Yang Application No.: Page 2

Respectfully submitted,

Richard T. Ogawa Reg. No. 37,692

TOWNSEND and TOWNSEND and CREW LLP Two Embarcadero Center, Eighth Floor San Francisco, California 94111-3834 Tel: 650-326-2400

Fax: 650-326-2422

RTO:dhe 60083274 v1

Substitute for form 1449B/PTO		Complete if Known		
INFORMATION DISCLOSURE STATEMENT BY APPLICANT			Application Number	
			Filing Date	
			First Named Inventor	Yang, Xiao
			Art Unit	
(use as many sheets as necessary)		Examiner Name		
Sheet	3	of	Attorney Docket Number	021713-000400US

U.S. PATENT DOCUMENTS+						
		Document Number				
Examiner Initials*	Cite No.1	Number Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
	AA	US-5,771,116	June 23, 1998	Miller et al.		
	AB	US-				
	AC	US-				
	AD	US-				
	AE	US-				
	AF	US-				
	AG	US-				

		FOREIGN PA	TENT DOCUME	NTS		
Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines,	
		Country Code ³ Number ⁴ Kind Code ⁶ (if known)			Where Releva Passages or Rel Figures Appe	Relevant
	AH					
	Al					
	AJ					
	AK				<u> </u>	
	T	NON PATENT LITERA Include name of the author (in CAPITAL LET	TERS), title of the a	article (when appropriate),	title of the item	
Examiner Initials *	Cite No.1	(book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.			T ²	
AL Larry J. Hombeck, "Digital Light Processing™: A New MEMS-Based Display Technology, Texas Instruments			nstruments			
	AM					
	AN					

Examiner	Date	
Signature	Considered	

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Applicant's unique citation designation number (optional). Applicant is to place a check mark here if English language Translation is attached.